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SERIAL NUMBER 10/815,813	FILING OR 371(c) DATE 04/02/2004 RULE	CLASS 438	GROUP ART UNIT 2814	ATTORNEY DOCKET NO. 0756-7283
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APPLICANTS

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** CONTINUING DATA *****

AC None

** FOREIGN APPLICATIONS *****

AC JAPAN 2003-101312 04/04/2003

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 06/16/2004

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 15	TOTAL CLAIMS 46	INDEPENDENT CLAIMS 8
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				

Verified and
Acknowledged

Examiner's Signature

Initials

ADDRESS

31780

TITLE

8/15/04 Method of fabricating semiconductor device utilizing laser irradiation

FILING FEE RECEIVED 1668	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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